

#23
Suppl
PATENT
97-CT-174
Response
Attach
Imperial
5/22/03IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
RAFFAELE ZAMBRANO)
Serial No.: 09/191,743)
Filed: November 13, 1998)
For: IN-SITU DEPOSITION AND)
DOPING PROCESS FOR POLY-)
CRYSTALLINE SILICON LAYERS)
AND THE RESULTING DEVICE)

Group Art Unit: 2823

Examiner: M. Estrada

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SUPPLEMENTAL RESPONSE

TECHNOLOGY CENTER 2800

VIA FACSIMILE

Commissioner for Patents
Washington, D.C. 20231

Sir:

In the Office Action dated April 11, 2001, the Examiner stated that the IDS filed November 13, 1998 failed to comply with 37 C.F.R. § 1.98(a)(3) because a concise explanation of the relevance of the EP 0 491 976 A1 reference was not provided. The U.S. counterpart of the German language EP 0 491 976 A1 reference issued on May 10, 1994 as U.S. Patent No. 5,310,698. Applicant submits that the '698 patent provides the necessary explanation of the German language EP 0 491 976 A1 reference that was listed on the IDS. Therefore, it is respectfully requested that the Examiner consider both the German language EP 0 491 976 A1 reference and the corresponding '698 patent. For the Examiner's convenience, a copy of U.S. Patent No. 5,310,698 is attached.

-2-

Respectfully submitted,

By: 

Stephen Bongini
Registration No. 40,917
Attorney for Applicant

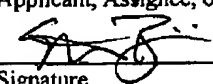
Date: May 7, 2003

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